

WHAT IS CLAIMED IS:

- 1 1. An imaging composition comprising:
2 a semiconductor nanocrystal having an outer layer bonded to the nanocrystal.
- 1 2. The composition of claim 1, wherein the semiconductor nanocrystal has a
2 diameter of between 5 nm and 10 nm.
- 1 3. The composition of claim 1, wherein the outer layer includes a polydentate ligand.
- 1 4. The composition of claim 1, wherein the nanocrystal emits light having a
2 wavelength greater than 700 nm.
- 1 5. The composition of claim 1, wherein the nanocrystal includes a core of a first
2 semiconductor material and an overcoating of a second semiconductor material on the core
3 wherein the first semiconductor material and the second semiconductor material are selected
4 so that, upon excitation, one carrier is substantially confined to the core and the other carrier
5 is substantially confined to the overcoating.
- 1 6. The composition of claim 1, wherein the semiconductor nanocrystal includes a
2 core of a first semiconductor material.
- 1 7. The composition of claim 6, wherein the first semiconductor material is a Group
2 II-VI compound, a Group II-V compound, a Group III-VI compound, a Group III-V
3 compound, a Group IV-VI compound, a Group I-III-VI compound, a Group II-IV-VI
4 compound, or a Group II-IV-V compound.
- 1 8. The composition of claim 6, wherein the first semiconductor material is ZnS,
2 ZnSe, ZnTe, CdS, CdSe, CdTe, HgS, HgSe, HgTe, AlN, AlP, AlAs, AlSb, GaN, GaP, GaAs,
3 GaSb, GaSe, InN, InP, InAs, InSb, TiN, TiP, TiAs, TiSb, PbS, PbSe, PbTe, or mixtures
4 thereof.

1 9. The composition of claim 6, wherein the semiconductor nanocrystal includes a
2 second semiconductor material overcoated on the first semiconductor material.

1 10. The composition of claim 9, wherein the first semiconductor material has a first
2 band gap, and the second semiconductor material has a second band gap that is larger than
3 the first band gap.

1 11. The composition of claim 9, wherein the second semiconductor material is a
2 Group II-VI compound, a Group II-V compound, a Group III-VI compound, a Group III-V
3 compound, a Group IV-VI compound, a Group I-III-VI compound, a Group II-IV-VI
4 compound, or a Group II-IV-V compound.

1 12. The composition of claim 9, wherein the second semiconductor material is ZnO,
2 ZnS, ZnSe, ZnTe, CdO, CdS, CdSe, CdTe, MgO, MgS, MgSe, MgTe, HgO, HgS, HgSe,
3 HgTe, AlN, AlP, AlAs, AlSb, GaN, GaP, GaAs, GaSb, InN, InP, InAs, InSb, TiN, TiP, TiAs,
4 TiSb, TlSb, PbS, PbSe, PbTe, or mixtures thereof.

1 13. A method of imaging tissue comprising:
2 introducing a composition including a semiconductor nanocrystal into the tissue; and
3 detecting emission from the semiconductor nanocrystal.

1 14. The method of claim 13, wherein the tissue is vasculature.

1 15. The method of claim 13, wherein the emission is in the near-infrared (NIR) or
2 infrared wavelength region.

1 16. The method of claim 13, wherein introducing the composition includes injecting
2 the composition into a body.

1 17. The method of claim 13, wherein introducing the composition includes injecting
2 the composition into a vascular system of a body.

1 18. The method of claim 17, wherein detecting emission includes monitoring tissue
2 or tumor vascular during surgery, monitoring body sites of bleeding during surgery, or
3 monitoring tissue perfusion during surgery and surgical repairs.

1 19. The method of claim 13, wherein the semiconductor nanocrystal has a diameter
2 of between 5 nm and 10 nm.

1 20. The method of claim 13, wherein the semiconductor nanocrystal has a diameter
2 of between 5 nm and 10 nm.

1 21. The method of claim 13, further comprising exposing the tissue to white light.

1 22. The method of claim 13, wherein the nanocrystal emits light having a wavelength
2 greater than 700 nm.

1 23. The method of claim 13, wherein the nanocrystal includes a core of a first
2 semiconductor material and an overcoating of a second semiconductor material on the core
3 wherein the first semiconductor material and the second semiconductor material are selected
4 so that, upon excitation, one carrier is substantially confined to the core and the other carrier
5 is substantially confined to the overcoating.